



*TEW*

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Masakazu SATO et al.

Group Art Unit: 2812

Application No.: 10/517,655

Docket No.: 122035

Filed: December 13, 2004

For: METHOD OF EVALUATING SHAPE OF SEMICONDUCTOR WAFER AND APPARATUS FOR EVALUATING SHAPE OF SEMICONDUCTOR WAFER

**SECOND REQUEST FOR CORRECTION OF PALM RECORDS**

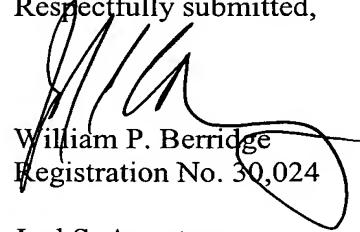
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

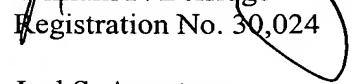
Sir:

A Request for Correction of PALM Records was filed on July 29, 2005. A copy of the Request, a marked-up copy of the Official Filing Receipt and a date stamped receipt is attached hereto.

It is respectfully requested that the Corrected Filing Receipt be immediately forwarded to the attorneys of record at the address set forth below.

Respectfully submitted,

  
William P. Berridge  
Registration No. 30,024

  
Joel S. Armstrong  
Registration No. 36,430

WPB:JSA/sml

Date: July 31, 2006

**OLIFF & BERRIDGE, PLC**  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**  
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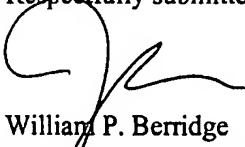
REQUEST FOR CORRECTION OF PALM RECORDS

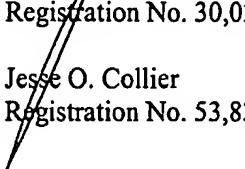
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

  
William P. Berridge  
Registration No. 30,024

  
Jesse O. Collier  
Registration No. 53,839

WPB:JOC/emt

Date: July 29, 2005

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UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/517,655	12/13/2004	2812	6600	122035	8	132	2

25944  
OLIFF & BERRIDGE, PLC  
P.O. BOX 19928  
ALEXANDRIA, VA 22320

CONFIRMATION NO. 7281

## FILING RECEIPT



\*OC000000016250423\*

Date Mailed: 06/13/2005

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

**Applicant(s)**

Masakazu Sato, Fukushima, JAPAN;  
Masato Onishi, Fukushima, JAPAN;

**Assignment For Published Patent Application**

SHIN-ETSU HANDOTAI CO LTD, Chiyoda-ku, JAPAN

**Power of Attorney:** The patent practitioners associated with Customer Number 25944.

**Domestic Priority data as claimed by applicant**

This application is a 371 of PCT/JP03/07320 06/10/2003

**Foreign Applications**

JAPAN 2002173268 06/11/2002

**Projected Publication Date:** 09/22/2005

**Non-Publication Request:** No

**Early Publication Request:** No

**Title**

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-Semiconductor wafer shape evaluating method and shape evaluating device  
Method of Evaluating Shape of Semiconductor Wafer and  
Preliminary Class  
438 Apparatus for Evaluating Shape of Semiconductor Wafer

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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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**The following papers have been filed:**

Request for Corr. of PALM Records w/marked-up copy OFR

**Name of Applicant:** Masakazu SATO et al.

**Serial No.:** 10/517,655

**Atty. File No.:** 122035

**Title (New Cases):**

**Sender's Initials:** WPB/emt

75 /  
35

**PATENT OFFICE DATE STAMP**



41

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